

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of )  
 )  
Tomotaka Yokoyama et al. )  
 )  
Serial No.: 10/761,771 )  
 )  
Filed: January 20, 2004 )  
 )  
For: Management Technique Of Friction )  
Coefficient Based On Surface Roughness, )  
Substrate For An Information Recording )  
Medium, Information Recording Medium )  
And Manufacturing Method Thereof )  
 )  
Art Unit: 1773 )  
 )  
Confirmation No.: 3525 )  
 )  
Examiner: Leszek B. Kiliman )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT C (AFTER FINAL)**

Sir:

In response to the Final Rejection of August 29, 2006, please enter the following amendment in the above-identified application: